

EXPRESS MAIL No.: EL 304052514 US

Deposited: December 14, 2006

I hereby certify that this correspondence is being deposited with the United States Postal Service Express Mail under 37 CFR 1.10 on the date indicated above and is addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-450

 / Ruth Montalvo Date: 12/14/06

Customer No. 026418

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney's Docket No.: JG-SU-5224/500577.20073

U.S. Application No.: 10/562,235

Filed: December 22, 2005

International Application No.: PCT/JP2005/006268

International Filing Date: MARCH 31, 2005

31 MARCH 2005

Priority Date Claimed: APRIL 05, 2004

04 APRIL 2004

Title of Invention: **MANUFACTURING METHOD OF SEMICONDUCTOR WAFER AND SEMICONDUCTOR WAFER MANUFACTURED BY THIS METHOD**

Applicant(s) for (DO/EO/US): **Syouji NOGAMI, Yukichi HORIOKA, and Shoichi YAMAUCHI**

Mail Stop PCT
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

S I R:

Applicant herewith submits this Information Disclosure Statement in accordance with the provisions of 37 C.F.R. §§ 1.97 and 1.98, and hereby make of record the following references:

Document Number	Date	Name and/or Country	English Translation and/or Equivalent
2001-196573	07/19/2001	Japan	English Abstract
2003-218037	07/31/2003	Japan	English Abstract

Accompanying this Supplemental Information Disclosure Statement and form PTO-1449 are copies of the documents including English Abstracts. These documents are cited against Japanese Patent Application No. 2004-110634, which is the priority document of this application.

The USPTO waived the requirement under 37 C.F.R. §1.98(a)(2)(i) for submitting copies of US patents and US patent application publications in all U.S. applications filed after June 30, 2003. First pages of US documents only.

This submission is not an admission that the information disclosed in the documents is material to the patentability of the invention disclosed and/or claimed in the above-identified application.

Respectfully submitted,

Dated: December 14, 2006



Jules E. Goldberg - Reg. No. 24,408
Reed Smith LLP
599 Lexington Avenue
New York, NY 10022-7650
Tel.: (212) 521-5400

JEG:jlw

LIST OF PRIOR ART CITED BY APPLICANT
(Filed on December 22, 2005)

Docket No. **JG-SU-5224/500577.20073**Applicant(s): **Syouji NOGAMI, Yukichi HORIOKA, and Shoichi YAMAUCHI**

Application No. 10/562,235 (Int'l Appln No. PCT/JP2004/006268 31MAY05) Group: Unassigned

Filed: December 22, 2005

Examiner: Unassigned

U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	CLASS	Sub-Class	Translation YES NO
	AL	2001-196573	07/19/2001	Japan			X
	AM	2003-218037	07/31/2003	Japan			X
	AN						
	AO						
	AP						
	AQ						
	AR						
	AS						
	AT						

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AX	
	AY	
	AZ	

Examiner:

Date:

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.